Attorney Docket No: 81848,0016,001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Art Unit:

1711

Chih-Chien Liu, et al.

Confirmation No. 4793

Serial No: 09/546,174

Examiner: Sergent, Rabon A.

Filed: April 11, 2000

For:

High Density Plasma Chemical Vapor Deposition

Process

CERTIFICATE OF ELECTRONIC TRANSMISSION

Date of Transmission: December 20, 2007

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that

- Revocation of Power of Attorney;
- New Power of Attorney and Correspondence Address Indication Form;
- Petition for Extension of Time (three months);
- Response to Office Action;
- authorization to charge Deposit Account the extension fee of \$1,050.00 and any deficiency of fees.

are being transmitted via electronic filing on the date indicated above to the: Commissioner for Patents, USPTO

Date: December 20, 2007

Hogan & Hartson, LLP 1999 Avenue of the Stars, Suite 1400 Los Angeles, California 90067

Telephone: 310-785-4600 Facsimile: 310-785-4601

Lillian E. Rodriguez

Name of person transmitting papers

Signature